Kinser, Robin D.

From: Rustemeier, Klaus
Sent: Tuesday, October 08, 2002 4:58 AM
To: Kinser, Robin D.
Subject: RE: biomarker selection

Dear Robin:

Sure, I will participate. I am looking forward to continue our enjoyable cooperation.
Best regards
Klaus

-----Original Message-----
From: Kinser, Robin D.
Sent: Tuesday, October 08, 2002 01:16
To: Rustemeier, Klaus; remote Holt, Klaus von; Schepers, Georg; Feng, Shixia; Tricker, Anthony; Patskan, George J.
Cc: Kinser, Robin D.; Roethig, Hans; Solana, Rick P.; Dempsey, Ruth; remote Reininghaus, Wolf; Haussmann, Hans-Juergen
Subject: biomarker selection

Dear Colleagues--

I'm sure you recall that a group collaborated in the selection of biomarkers of exposure for the Total Exposure Study. As our work in Clinical Evaluation continues, we are asked to evaluate new products for which the initial biomarker selections may not be the most appropriate. The development of analytical techniques also has continued, and some biomarkers which were desirable for study but were not readily analyzable have been the subject of method development efforts and may now be quantified. With these facts in mind, I have spoken to Hans Roethig about setting up an internal panel for the review and acceptance (or rejection) of new biomarkers. The membership I propose for this panel is Shixia Feng, Klaus von Holt, Robin Kinser, George Patskan, Klaus Rustemeier, Georg Schepers, and Tony Tricker.

We would conduct our work via teleconferences as much as possible. I suspect the literature we would all be reviewing is cigarette smoke related literature that we each are reading anyway. Therefore, I don't think the work of this panel would interfere significantly with the current work commitments.

Please let me know of you availability to participate on this panel. I anticipate an inaugural conference call by the end of October.

I'm hoping you will all say "yes" to this request, and I will thank you in advance for your interest.

Best regards,
Robin

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